

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	IS&R	L1	386	(310/318).CCLS.	USPA T	2003/02/24 14:40	
2	IS&R	L2	68	(310/318).CCLS.	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/24 14:43	
3	BRS	L3	1954	wave and (microswitch or micro adj1 switch or electromechanical adj1 switch or electro adj1 mechanical adj1 switch)	USPA T	2003/02/24 14:49	
4	BRS	L4	792	13 and filter\$	USPA T	2003/02/24 14:48	
5	BRS	L5	26	wave and substrate\$1 same (microswitch or micro adj1 switch or electromechanical adj1 switch or electro adj1 mechanical adj1 switch)	USPA T	2003/02/24 15:00	
6	BRS	L6	13	bulk and substrate\$1 same (microswitch or micro adj1 switch or electromechanical adj1 switch or electro adj1 mechanical adj1 switch)	USPA T	2003/02/24 15:03	
7	BRS	L7	12	wave and substrate\$1 same (microswitch or micro adj1 switch or electromechanical adj1 switch or electro adj1 mechanical adj1 switch)	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/24 15:01	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
8	BRS	L8	10	bulk and substrate\$1 same (microswitch or micro adj1 switch or electromechanical adj1 switch or electro adj1 mechanical adj1 switch)	US-P GPUB ; EPO; JPO; DERW ENT; IBM- TDB	2003/02/24 15:04	